

<b>Notice of References Cited</b>	Application/Control No. 10/615,979	Applicant(s)/Patent Under Reexamination YASHIRO, SADA0	
	Examiner Thu V. Huynh	Art Unit 2178	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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**NON-PATENT DOCUMENTS**

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